



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA et al.

Group Art Unit: 1714

Application No.: 10/586,953

Examiner: M. SONG

Filed: July 25, 2006

Docket No.: 128832

For: A SILICON SINGLE CRYSTAL, A SILICON WAFER, AN APPARATUS FOR PRODUCING THE SAME, AND A METHOD FOR PRODUCING THE SAME

**AMENDMENT WITH REQUEST FOR CONTINUED EXAMINATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In further reply to the March 4, 2011 Final Rejection, in view of the June 20, 2011 Advisory Action, and upon entry of the attached Request for Continued Examination, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**